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a reflectance," whereas independent claims 11 and 16 lack such limitations. Claims 20-31 have been canceled without prejudice so that claims 11-19 can issue without declaration of an interference.

Claims 11-19 remain patentably distinct from the claims in the parent application (Serial No. 08/401,229), as they do not require interferometric detection.

Attached is a marked-up version of the changes being made by the current amendment.

Applicant asks that all claims be examined. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

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Version with markings to show changes made

In the claims:

Claims 1-10 and 20-31 have been cancelled.

Claims 11 and 16 have been amended as follows:

11. (Amended) A chemical mechanical polisher for planarizing a film on one side of a substrate having two sides comprising at least one light source that transmits light [through] toward the substrate from the side of the substrate with the film to illuminate at least one section on the film [creating] and create at least one reflected light signal that is received by at least one device that monitors a dimensional change based on the reflected light signal.

16. (Amended) A chemical mechanical polisher for planarizing a film on one side of a substrate having two sides comprising at least one light source that transmits light [through] toward the substrate from the side of the substrate with the film to illuminate at least one section on the film [creating] and create at least one reflected light signal that is received by at least one means for monitoring thickness change based on the reflected light signal.